

Serial No. 09/744,152

Group: 1765

Filed: January 22, 2001

Examiner: V. Perez Ramos

For: SILICON MICRO-MACHINED PROJECTION WITH DUCT

\* \* \* \* \* \* \* \* \* \*

May 19, 2003

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

## **AMENDMENT**

This Amendment is responsive to the Official Action mailed December 18, 2002 (Paper No. 7), the date of response to which has been extended two months up to and including May 19, 2003 (May 18, 2003 falling on a Sunday) in view of the attached two-month extension of time petition and petition fee.

05/20/2003 CCHAU1

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